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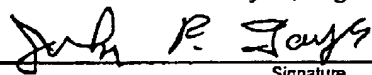
FACIMILE TRANSMISSION COVER SHEET

To: Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

☒ In re application of:

Appl. No.: 10/619,978
Applicants: Yong-Bae Kim and Philippe Schoenborn
Filed: July 14, 2003
TC/A.U.: 1765
Examiner: Kin-Chan Chen
Title: PROCESS FOR REMOVAL OF PHOTORESIST MASK USED FOR MAKING VIAS
IN LOW K CARBON-DOPED SILICON OXIDE DIELECTRIC MATERIAL, AND
FOR REMOVAL OF ETCH RESIDUES FROM FORMATION OF VIAS AND
REMOVAL OF PHOTORESIST MASK
Docket No.: 01-125/1C

CERTIFICATION OF FACSIMILE TRANSMISSION	
I hereby certify that the accompanying amendment is being facsimile transmitted to the Patent and Trademark Office (Fax No. (703) 872-9306) on the date shown below;	
on	<u>May 23, 2005</u> (Date of Facsimile Transmission)
John P. Taylor, Reg. No. 22,369	
	_____ Signature
<u>May 23, 2005</u> Date of Signature	

Total Pages (including this cover sheet): 16
Documents included:
Fax Cover Sheet 1 Pages
Amendment Transmittal Letter 2 Pages
Amendment 11 Pages
Terminal Disclaimer 2 Pages

AMENDMENT TRANSMITTAL LETTER			ATTORNEY'S DOCKET NO. 01-125/1C
SERIAL NO. 10/619,978	FILING DATE July 14, 2003	EXAMINER Kin-Chan Chen	GROUP ART UNIT 1765
INVENTION PROCESS FOR REMOVAL OF PHOTORESIST MASK USED FOR MAKING VIAS IN LOW K CARBON-DOPED SILICON OXIDE DIELECTRIC MATERIAL, AND FOR REMOVAL OF ETCH RESIDUES FROM FORMATION OF VIAS AND REMOVAL OF PHOTORESIST MASK			

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS:

Transmitted herewith is an amendment in the above-identified application.

Small entity status of this application under 37 CAR 1.27 has been established by a verified statement previously submitted.

A verified statement to establish small entity status under 37 CAR 1.9 and 1.27 is enclosed.

☒ No additional fee is required.☐ The fee has been calculated as shown below:

	(1)		(2)	(3)
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA
TOTAL	* 5	MINUS	** 20	* 0
INDEP.	* 3	MINUS	*** 3	* 0
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				

SMALL ENTITY		OR	OTHER THAN A SMALL ENTITY	
RATE	ADDIT. FEE		RATE	ADDIT. FEE
x \$25 =	\$		x \$50 =	\$ 0
x \$100 =	\$		x \$200 =	\$ 0
+ \$180 =	\$		+ \$360 =	\$ 0
TOTAL ADDIT. FEE	\$	OR	TOTAL	\$ 0

* If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3.

** If the "Highest No. Previously Paid For" IN THIS SPACE is less than 20, enter "20".

*** If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, enter "3".

The "Highest No. Previously Paid For" (Total or indep.) is the highest number found in the appropriate box in Col. 1.

Please charge Deposit Account No. _____ in the amount of \$ _____.
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A check in the amount of \$ _____ to cover the filing fee is enclosed.

☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-2252. A Duplicate copy of this sheet is enclosed.

Any additional filing fees required under 37 CAR 1.16.

Any patent application processing fees under 37 CAR 1.17.

May 23, 2005
(Date)

John P. Taylor
(Signature)

John P. Taylor
Reg No. 22,369
Telephone No. (951) 303-1416

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SERIAL NO. 10/619,978	FILING DATE July 14, 2003	EXAMINER Kin-Chan Chen	GROUP ART UNIT 1765
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	(1)	(2)	(3)	
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA
TOTAL	5	MINUS	20	0
INDEP.	3	MINUS	3	0
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				

SMALL ENTITY

RATE	ADDIT. FEE
x \$25 =	\$
x \$100 =	\$
+ \$180 =	\$
TOTAL ADDIT. FEE	\$

OTHER THAN A
SMALL ENTITY

RATE	ADDIT. FEE
x \$50 =	\$ 0
x \$200 =	\$ 0
+ \$360 =	\$ 0
TOTAL	\$ 0

* If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3.

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